

Electronic Patent Application Fee Transmittal

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| Application Number: | 10790457 |
| Filing Date: | 01-Mar-2004 |
| Title of Invention: | Method for removal of immersion lithography medium in immersion lithography processes |
| First Named Inventor/Applicant Name: | Adam R. Pawloski |
| Filer: | Thomas W. Adams/Janet Farr |
| Attorney Docket Number: | H1559 |

Filed as Large Entity

Utility Filing Fees

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

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| Notice of appeal | 1401 | 1 | 500 | 500 |
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Post-Allowance-and-Post-Issuance:

Extension-of-Time:

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|--------------------------|----------|----------|--------|----------------------|
| Miscellaneous: | | | | |
| Total in USD (\$) | | | | 500 |